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PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3210

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Takeshi Shibata et al.	)	Group Art Unit: 2823
	)	
Application No.: 10/743,522	)	Examiner: NGUYEN, Khiem D.
	)	
Filed: December 23, 2003	)	
	)	
For: STENCIL MASK WITH	)	Confirmation No.: 7673
CHARGE-UP PREVENTION AND	)	
METHOD OF MANUFACTURING	)	
THE SAME	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

In a restriction requirement mailed September 30, 2005, the period for response to which extends through October 30, 2005, the Examiner required restriction under 35 U.S.C. § 121 between Group I, claims 1-28 and 35, characterized by the Examiner as being drawn to a stencil mask; and Group II, claims 29-34, characterized by the Examiner as being drawn to a stencil mask manufacturing method. Applicants elect to prosecute Group I, claims 1-28 and 35, without traverse.

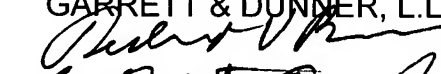
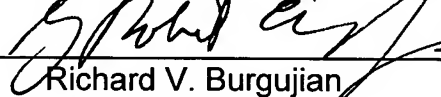
Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: October 27, 2005

By:

  
 #27,432  
Richard V. Burgujian  
Reg. No. 31,744